

ПОЗДРАВЛЯЕМ ЮБИЛЯРА!

Директору Центра микротехнологии и диагностики ЛЭТИ, научному руководителю Научно-образовательного центра "Нанотехнологии", доктору технических наук профессору **ВИКТОРУ ВИКТОРОВИЧУ ЛУЧИНИНУ** 22 сентября 2010 г. исполнилось 60 лет.

Талантливый ученый и преподаватель, Виктор Викторович является автором ряда актуальных исследований в области физики и технологии сенсорных и информационных нано- и микросистем на основе неорганических и биоорганических материалов, обладающих полиморфизмом. Научно-практическая деятельность его связана с руководством ряда НИОКР, направленных на создание микро- и наноразмерных приборов экстремальной электроники и биосенсорики, а также на разработку методов атомно-, электронно- и ионно-зондовой диагностики и тестирования интегральных схем и биообъектов на информационную и биологическую безопасность.

Виктор Викторович является заместителем главного редактора нашего журнала, членом редколлегий ряда других научно-технических журналов.

Высокий профессионализм, широкая эрудиция, большая трудоспособность снискали ему большое уважение друзей и коллег.

Сердечно поздравляем юбиляра и желаем ему крепкого здоровья и новых творческих успехов!

Редколлегия и редакция

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Keywords: nanotechnology, polymeric nanocompounds, carbon nanotubes

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Keywords: probe microscopy, tunneling microscope, interpretation of STM measurements, probe tip shape

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Keywords: ferroelectrics, chemical solution deposition, alkoxide, polarization, hysteresis

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Keywords: submillimeter (terahertz) range of wavelengths (frequencies), superconducting direct detectors, superconducting bolometer, transition edge sensors, thin superconducting film, technology of micron, submicron and nanometer-superconductor structures, electron-beam

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Keywords: productivity, an electronic component, the soldering, temperature, the soldering furnace

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Keywords: automatic phasing of signals, on chip isodromic circuit

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Keywords: nanotransistors, metal-oxide-semiconductor, nanoelectronics

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Keywords: piezoresistive sensor of mechanical quantities, sensitive element; MEMS (microelectromechanical systems); criterion of sensors quality; informativity of signal, resolution, noise voltage, energy of deformation, microminiaturization, nanosensor

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Keywords: piezoelectric, oscillation mode, bimorph, Coriolis force, finite element method, piezohyroscope, sensitivity to revolving

Usanov D. A., Skripal A. V., Dobdin S. Yu. *The Acceleration Determination at Unevenly Accelerated at Micro- and Nanodisplacements by the Autodine Signal of Semiconductor Laser*. 51

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Keywords: semiconductor laser, autodine, signal, acceleration measurement, micro- and nanodisplacements

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